IN THE

TED STATES PATENT AND TRADE

JC12 Rec'd PCT/PTO 02 MAY 2005

In re the Application of Akira SAKURAI et al.

Application No.: New U.S. National

PCT/JP03/013837

Filed: May 2, 2005

Docket No.: 123653

For:

A METHOD FOR FORMING A THIN FILM OF SILVER MIRROR AND A METHOD FOR FORMING A COATED FILM CONTAINING SAID THIN FILM OF SILVER MIRROR

Stage

of

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the non-English language references 6 and 14 is discussed in the present specification.
- 3. The references 1-2 and 5-12 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 5. English language Abstracts of the non-English language references 3-11 and 13-14 are attached hereto.
- 6. A computer-generated English language translation of the Japanese Patent Publications 3-8, 10-11 and 13-14 has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy.

Respectfally submitted

James A. Oliff

Registration No. 27,075

Thomas J. Pardini Registration No. 30,411

JAO:TJP/cqc
Date: May 2, 2005
OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

10/533546 JC12 Rec CT/PTC 02 MAY 2005 Sheet 1 of 1

Form PTO-1449 (REV. 8-83)	•			ATTY DOCKET NO. 123653			APPLICATION NO. New U.S. National Stage of PCT/JP03/013837		
INFOI	RMATI	ON DISCLOSURE STATEMENT					PC1/.	JP03/01383	1
	(Use s	several sheets if necessary)	APPLICANTS Akira SAKURAI et al.						
			FILING DATE May 2, 2005						
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAN	и́Е		CLASS	SUB CLASS
	1)	5,716,433	02/10/1998		AONUMA et al.				
	2)	US 6,398,854 B1	06/04/2002		AONUMA				
FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	<u> </u>	DATE	COUNT	ΓRY		CLASS	SUB CLASS
	3)	JP A 2000-234175 w/ abst. & trans	08/2	29/2000	JAPAN				
	4)	JP A 9-87858 w/ abstract & trans	03/3	31/1997	JAPAN				
	5)	JP A 11-186697 w/ abstract & trans	07/0	09/1999	JAPAN				
	6)	JP A 2001-46958 w/ abst. & trans	02/2	20/2001	JAPAN				
	7)	JP A 2000-129452 w/ abst.& trans	05/0	09/2000	JAPAN				
	8)	JP A 2000-243119 w/ abst. & trans	09/0	082000	JAPAN				
	9)	JP B2 63-34228 w/ abstract	07/0	08/1988	JAPAN				
	10)	JP A 2000-73178 w/ abst. & trans	03/0	07/2000	JAPAN				
	11)	JP A 6-49653 w/ abstract & trans	02/2	22/1994	JAPAN				
	12)	WO 93/10975 A1	06/1	10/1993	WIPO				
	13)	JP A 6-38860 w/ abstract & trans	02/1	15/1994	JAPAN				
	14)	JP A 11-335858 w/ abstract & trans	12/0	07/1999	JAPAN				
	-	OTHER DOCUMENTS (Inc	cludin	ig Author, 7	Γitle, Date, Pertinent Pag	ges, etc.)			
					w.n.				
<u> </u>								<u></u>	
ļ									
					· · · · · · · · · · · · · · · · · · ·				
l									
EXAMINER					DATE CO	OATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

Date: May 2, 2005